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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Kirk Martin
Assignee: Nisene Technology Group
Title: Method and Apparatus for Etching a Semiconductor Die
Serial No.: 09/902,931 Filing Date: July 10, 2001
Examiner: Vinh, Lan Group Art Unit: 1765
Docket No.: M-11706 US
(NTG-P101)

San Jose, California

COMMISSIONER FOR PATENTS
Washington, D.C. 20231

**REVOCATION OF POWER OF ATTORNEY AND
POWER OF ATTORNEY BY ASSIGNEE OF ENTIRE INTEREST**

Sir:

Nisene Technology Group, the assignee of record of the above-identified application, hereby revokes all powers of attorney previously given and appoints the attorney(s) and/or agent(s) identified below to prosecute the above-identified application and to transact all business in the United States Patent and Trademark Office in connection therewith:

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Please address all correspondence and telephone calls regarding these patent and patent applications to:

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ASSIGNEE CERTIFICATION UNDER 37 CFR 3.73(b)

The undersigned representative of the above-referenced assignee certifies that the above-referenced assignee is the assignee of the entire right, title and interest in the above-referenced patent application by virtue of a chain of title from the inventor of the above-referenced patent application to the above-referenced assignee as shown below:

1. From: Kirk Martin To: Nisene Technology Group. The document was recorded in the Patent and Trademark Office at Reel 011992, Frame 0478.

The undersigned (whose title is provided below) is empowered to sign this certificate on behalf of the above-referenced assignee.

Date: February 7, 2003

Nisene Technology Group

By: 

Name: Alan Wagner

Title: Chief Executive Officer